

# Osamu Tabata

## List of Publications by Year in descending order

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222  
papers

3,694  
citations

201385

27  
h-index

168136

53  
g-index

267  
all docs

267  
docs citations

267  
times ranked

3052  
citing authors

#	ARTICLE	IF	CITATIONS
1	Anisotropic etching of silicon in TMAH solutions. <i>Sensors and Actuators A: Physical</i> , 1992, 34, 51-57.	2.0	416
2	Mechanical property measurements of thin films using load-deflection of composite rectangular membranes. <i>Sensors and Actuators</i> , 1989, 20, 135-141.	1.8	360
3	Specimen size effect on tensile strength of surface-micromachined polycrystalline silicon thin films. <i>Journal of Microelectromechanical Systems</i> , 1998, 7, 106-113.	1.7	335
4	Ciliary motion actuator using self-oscillating gel. <i>Sensors and Actuators A: Physical</i> , 2002, 95, 234-238.	2.0	117
5	Moving mask UV lithography for three-dimensional structuring. <i>Journal of Micromechanics and Microengineering</i> , 2007, 17, 199-206.	1.5	113
6	Integrated heart/cancer on a chip to reproduce the side effects of anti-cancer drugs in vitro. <i>RSC Advances</i> , 2017, 7, 36777-36786.	1.7	98
7	Stafne's bone cavity. <i>Oral Surgery, Oral Medicine, and Oral Pathology</i> , 1993, 76, 375-380.	0.6	87
8	Replica multichannel polymer chips with a network of sacrificial channels sealed by adhesive printing method. <i>Lab on A Chip</i> , 2005, 5, 472.	3.1	81
9	Monolithic pyroelectric infrared image sensor using PVDF thin film. <i>Sensors and Actuators A: Physical</i> , 1998, 66, 237-243.	2.0	80
10	A novel fabrication process of 3D microstructures by double exposure in deep x-ray lithography (D2XRL). <i>Journal of Micromechanics and Microengineering</i> , 2005, 15, 2056-2062.	1.5	63
11	High-Performance Genetic Analysis on Microfabricated Capillary Array Electrophoresis Plastic Chips Fabricated by Injection Molding. <i>Analytical Chemistry</i> , 2005, 77, 2140-2146.	3.2	63
12	pH-controlled TMAH etchants for silicon micromachining. <i>Sensors and Actuators A: Physical</i> , 1996, 53, 335-339.	2.0	61
13	Fast-response silicon flow sensor with an on-chip fluid temperature sensing element. <i>IEEE Transactions on Electron Devices</i> , 1986, 33, 361-365.	1.6	54
14	Noise-induced chaos in the electrostatically actuated MEMS resonators. <i>Physics Letters, Section A: General, Atomic and Solid State Physics</i> , 2011, 375, 2903-2910.	0.9	51
15	Hybrid Dynamic Coating with n-Dodecyl $\beta$ -d-Maltoside and Methyl Cellulose for High-Performance Carbohydrate Analysis on Poly(methyl methacrylate) Chips. <i>Analytical Chemistry</i> , 2006, 78, 1452-1458.	3.2	48
16	Mixing speed-controlled gold nanoparticle synthesis with pulsed mixing microfluidic system. <i>Microfluidics and Nanofluidics</i> , 2010, 9, 1165-1174.	1.0	47
17	Imaging and measuring the rituximab-induced changes of mechanical properties in B-lymphoma cells using atomic force microscopy. <i>Biochemical and Biophysical Research Communications</i> , 2011, 404, 689-694.	1.0	46
18	Improved Designs for an Electrothermal In-Plane Microactuator. <i>Journal of Microelectromechanical Systems</i> , 2012, 21, 586-595.	1.7	42

#	ARTICLE	IF	CITATIONS
19	Tensile Testing of Polycrystalline Silicon Thin Films Using Electrostatic Force Grip.. IEEJ Transactions on Sensors and Micromachines, 1996, 116, 441-446.	0.0	37
20	Reliability of ultrasonography and sialography in the diagnosis of sjögren's syndrome. Oral Surgery Oral Medicine Oral Pathology Oral Radiology and Endodontics, 1997, 83, 400-407.	1.6	36
21	Long-term outcomes of nonsurgical treatment in nonreducing anteriorly displaced disk of the temporomandibular joint. Oral Surgery Oral Medicine Oral Pathology Oral Radiology and Endodontics, 1998, 85, 258-267.	1.6	36
22	Clinical symptoms of open lock position of the condyle. Oral Surgery, Oral Medicine, and Oral Pathology, 1992, 74, 143-148.	0.6	35
23	Investigation of a New High Sensitive Micro-Electromechanical Strain Gauge Sensor Based on Graphene Piezoresistivity. Key Engineering Materials, 0, 605, 207-210.	0.4	34
24	Micro fabricated tunable bending stiffness devices. Sensors and Actuators A: Physical, 2001, 89, 119-123.	2.0	32
25	Investigating the sequence-dependent mechanical properties of DNA nicks for applications in twisted DNA nanostructure design. Nucleic Acids Research, 2019, 47, 93-102.	6.5	31
26	Monolithic pressure-flow sensor. IEEE Transactions on Electron Devices, 1987, 34, 2456-2462.	1.6	30
27	Micropowder blasting with nanoparticles dispersed polymer mask for rapid prototyping of glass chip. Journal of Micromechanics and Microengineering, 2005, 15, 1236-1241.	1.5	30
28	Electrostatic Tensile Testing Device With Nanonewton and Nanometer Resolution and Its Application to $C_{60}$ Nanowire Testing. Journal of Microelectromechanical Systems, 2012, 21, 523-529.	1.7	29
29	Two-axis detection resonant accelerometer based on rigidity change. Sensors and Actuators A: Physical, 1999, 75, 53-59.	2.0	28
30	Reduction of surface roughness and aperture size effect for etching of Si with XeF <sub>2</sub> . Journal of Micromechanics and Microengineering, 2002, 12, 911-916.	1.5	28
31	Range of Motion of the Temporomandibular Joint in Rheumatoid Arthritis: Relationship to the Severity of Disease. Cranio - Journal of Craniomandibular Practice, 1998, 16, 162-167.	0.6	27
32	Tensile and Tensile-Mode Fatigue Testing of Microscale Specimens in Constant Humidity Environment. Experimental Mechanics, 2010, 50, 509-516.	1.1	27
33	Micromachined Tactile Sensor for Soft-Tissue Compliance Detection. Journal of Microelectromechanical Systems, 2012, 21, 635-645.	1.7	27
34	Control of internal stress and Young's modulus of Si <sub>3</sub> N <sub>4</sub> and polycrystalline silicon thin films using the ion implantation technique. Applied Physics Letters, 1990, 56, 1314-1316.	1.5	26
35	Highly conductive transparent F-doped tin oxide films were prepared by photo-CVD and thermal-CVD. Thin Solid Films, 1996, 281-282, 228-231.	0.8	25
36	Multiple ion sensor array. Sensors and Actuators B: Chemical, 1990, 1, 8-11.	4.0	23

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37	Imaging of a band for DNA fragment migrating in microchannel on integrated microchip. <i>Materials Science and Engineering C</i> , 2000, 12, 33-36.	3.8	23
38	Phenotypic and Transcriptional Modulation of Human Pluripotent Stem Cells Induced by Nano/Microfabrication Materials. <i>Advanced Healthcare Materials</i> , 2013, 2, 287-291.	3.9	23
39	Morphologic analysis of odontogenic cysts with computed tomography. <i>Oral Surgery Oral Medicine Oral Pathology Oral Radiology and Endodontics</i> , 1997, 83, 712-718.	1.6	22
40	Embedded Microstructure Fabrication Using Developer-Permeability of Semi-Cross-Linked Negative Resist. <i>Journal of Microelectromechanical Systems</i> , 2010, 19, 1058-1069.	1.7	22
41	Validation of X-Ray Lithography and Development Simulation System for Moving Mask Deep X-Ray Lithography. <i>Journal of Microelectromechanical Systems</i> , 2006, 15, 159-168.	1.7	21
42	Tensile Strength of Silicon Nanowires Batch-Fabricated into Electrostatic MEMS Testing Device. <i>Applied Sciences (Switzerland)</i> , 2018, 8, 880.	1.3	21
43	Fabrication of Plastic Micro Tip Array using Laser Micromachining of Nanoparticles Dispersed Polymer and Micromolding. <i>IEEJ Transactions on Sensors and Micromachines</i> , 2006, 126, 7-13.	0.0	21
44	Versatile Method of Submicroparticle Pattern Formation Using Self-Assembly and Two-Step Transfer. <i>Journal of Microelectromechanical Systems</i> , 2007, 16, 746-752.	1.7	19
45	Effects of aperture size and pressure on XeF <sub>2</sub> etching of silicon. <i>Microsystem Technologies</i> , 2002, 9, 11-16.	1.2	18
46	A three-dimensional microstructuring technique exploiting the positive photoresist property. <i>Journal of Micromechanics and Microengineering</i> , 2010, 20, 065005.	1.5	18
47	Simulation of mechanical properties of epoxy-based chemically amplified resist by coarse-grained molecular dynamics. <i>Polymer</i> , 2012, 53, 4834-4842.	1.8	18
48	Graphene film development on flexible substrate using a new technique: temperature dependency of gauge factor for graphene-based strain sensors. <i>Sensor Review</i> , 2016, 36, 140-147.	1.0	18
49	Dependence of the hardness of titanium nitride prepared by plasma chemical vapour deposition on the gas flow rate and the r.f. power. <i>Thin Solid Films</i> , 1986, 137, L49-L50.	0.8	17
50	The Significance of Posterior Open Bite After Anterior Repositioning Splint Therapy for Anteriorly Displaced Disk of the Temporomandibular Joint. <i>Cranio - Journal of Craniomandibular Practice</i> , 1993, 11, 146-152.	0.6	17
51	Experimental Study of Numerical Optimization for 3-D Microstructuring Using DMD-Based Grayscale Lithography. <i>Journal of Microelectromechanical Systems</i> , 2015, 24, 1856-1867.	1.7	17
52	Electrolytes in erythrocytes of patients with depressive disorders. <i>Psychiatry and Clinical Neurosciences</i> , 1998, 52, 529-533.	1.0	16
53	Application of Nanoparticles Dispersed Polymer to Micropowder Blasting Mask. <i>Journal of Microelectromechanical Systems</i> , 2004, 13, 1-6.	1.7	16
54	Design and Simulation of a Tactile Sensor for Soft-Tissue Compliance Detection. <i>IEEJ Transactions on Sensors and Micromachines</i> , 2008, 128, 186-192.	0.0	16

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55	Shape memory thin films formed with carousel-type magnetron sputtering apparatus. <i>Smart Materials and Structures</i> , 2005, 14, S216-S222.	1.8	15
56	Mechanical calibration of MEMS springs with sub-micro-Newton force resolution. <i>Sensors and Actuators A: Physical</i> , 2008, 143, 136-142.	2.0	15
57	Design and fabrication of a differential capacitive three-axis SOI accelerometer using vertical comb electrodes. <i>IEEJ Transactions on Electrical and Electronic Engineering</i> , 2009, 4, 345-351.	0.8	15
58	Digital compensated capacitive pressure sensor using CMOS technology for low-pressure measurements. <i>Sensors and Actuators A: Physical</i> , 1992, 34, 173-177.	2.0	14
59	3-Dimensional Microstructure Fabrication using Multiple Moving Mask Deep X-ray Lithography Process. <i>IEEJ Transactions on Sensors and Micromachines</i> , 2000, 120, 321-326.	0.0	14
60	ALA-induced fluorescence detection with photoresist-based microfluidic cell sorter for bladder cancer diagnosis. <i>Sensors and Actuators B: Chemical</i> , 2015, 213, 547-557.	4.0	13
61	Direct measurement of transversely isotropic DNA nanotube by force-distance curve-based atomic force microscopy. <i>Micro and Nano Letters</i> , 2015, 10, 513-517.	0.6	13
62	Moving mask deep X-ray lithography system with multi stage for 3-D microfabrication. <i>Microsystem Technologies</i> , 2002, 8, 93-98.	1.2	11
63	Fatigue characteristics of polycrystalline silicon thin-film membrane and its dependence on humidity. <i>Journal of Micromechanics and Microengineering</i> , 2013, 23, 035032.	1.5	11
64	Coarse-Grained Molecular Dynamics Model of Double-Stranded DNA for DNA Nanostructure Design. <i>Journal of Physical Chemistry B</i> , 2017, 121, 5033-5039.	1.2	11
65	Effect of substrate bias voltage on tensile properties of single crystal silicon microstructure fully coated with plasma CVD diamond-like carbon film. <i>Applied Surface Science</i> , 2018, 443, 48-54.	3.1	11
66	Geometrical compensation for mode-matching of a (100) silicon ring resonator for a vibratory gyroscope. <i>Japanese Journal of Applied Physics</i> , 2019, 58, SDDL06.	0.8	11
67	Fracture strength of silicon torsional mirror resonators fully coated with submicrometer-thick PECVD DLC film. <i>Sensors and Actuators A: Physical</i> , 2019, 286, 28-34.	2.0	11
68	Frequency response of in-plane coupled resonators for investigating the acceleration sensitivity of MEMS tuning fork gyroscopes. <i>Microsystem Technologies</i> , 2012, 18, 797-803.	1.2	10
69	Tensile fracture of integrated single-crystal silicon nanowire using MEMS electrostatic testing device. <i>Procedia Structural Integrity</i> , 2016, 2, 1405-1412.	0.3	10
70	Three-dimensional simulation of powder blasting with a polymer mask using a cellular automaton. <i>Journal of Micromechanics and Microengineering</i> , 2008, 18, 055010.	1.5	9
71	On-chip fabrication of alkali-metal vapor cells utilizing an alkali-metal source tablet. <i>Journal of Micromechanics and Microengineering</i> , 2013, 23, 115003.	1.5	9
72	High-temperature tensile testing machine for investigation of brittle-ductile transition behavior of single crystal silicon microstructure. <i>Japanese Journal of Applied Physics</i> , 2015, 54, 06FP04.	0.8	9

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73	Nanopore Fabrication of Two-Dimensional Materials on SiO <sub>2</sub> Membranes Using He Ion Microscopy. IEEE Nanotechnology Magazine, 2018, 17, 727-730.	1.1	9
74	A Closer Look at DNA Nanotechnology. IEEE Nanotechnology Magazine, 2010, 4, 13-17.	0.9	8
75	A high-efficient driving isolated Drive-by-Microwave half-bridge gate driver for a GaN inverter. , 2016, , .		8
76	A heuristic approach for actuator layout designs in deformable mirror devices based on current value optimization. Structural and Multidisciplinary Optimization, 2018, 58, 1243-1254.	1.7	8
77	Body on a Chip: Re-Creation of a Living System In Vitro. IEEE Nanotechnology Magazine, 2013, 7, 6-14.	0.9	7
78	Characterization of alkali-metal vapor cells fabricated with an alkali-metal source tablet. Journal of Vacuum Science and Technology A: Vacuum, Surfaces and Films, 2016, 34, 061601.	0.9	7
79	Tuning porosity and radial mechanical properties of DNA origami nanotubes via crossover design. Japanese Journal of Applied Physics, 2017, 56, 06GJ02.	0.8	7
80	Formation of gold nanoparticle dimers on silicon by sacrificial DNA origami technique. Micro and Nano Letters, 2017, 12, 854-859.	0.6	7
81	Infrared linear image sensor using a poly-Si pn junction diode array. Infrared Physics, 1992, 33, 229-236.	0.5	6
82	Design Construction of Beam Structured Vertical Drive SMA Thin Film Actuator for Small Tactile Display. IEEJ Transactions on Sensors and Micromachines, 2008, 128, 151-160.	0.0	6
83	Effect of Surface Morphology and Crystal Orientations on Tensile Fracture Property of (110) Single Crystal Silicon. Nihon Kikai Gakkai Ronbunshu, A Hen/Transactions of the Japan Society of Mechanical Engineers, Part A, 2013, 79, 1191-1200.	0.2	6
84	Improvement of tensile strength of freestanding single crystal silicon microstructures using localized harsh laser treatment. Japanese Journal of Applied Physics, 2014, 53, 06JM03.	0.8	6
85	A compact Drive-by-Microwave gate driver with coupler integrated in a package. , 2014, , .		6
86	A Drive-by-Microwave isolated gate driver with a high-speed voltage monitoring. , 2014, , .		6
87	Ultrasensitive surface-enhanced Raman spectroscopy using directionally arrayed gold nanoparticle dimers. , 2015, , .		6
88	A compact GaN Bi-directional switching diode with a GaN Bi-directional power switch and an Isolated gate driver. , 2016, , .		6
89	Fracture behavior of single crystal silicon with thermal oxide layer. Engineering Fracture Mechanics, 2016, 163, 523-532.	2.0	6
90	Dry etching and low-temperature direct bonding process of lithium niobate wafer for fabricating micro/nano channel device. , 2017, , .		6

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91	Design strategy of electrode patterns based on finite element analysis in microfluidic device for Trans-epithelial Electrical Resistance (TEER) measurement. Electronics and Communications in Japan, 2021, 104, e12296.	0.3	6
92	Design Approaches and Computational Tools for DNA Nanostructures. IEEE Open Journal of Nanotechnology, 2021, 2, 86-100.	0.9	6
93	Recognition of the epicardial breakthrough on body surface isopotential maps: Influence of the inter-electrode distance on the patterns reflecting the epicardial breakthrough.. Japanese Circulation Journal, 1981, 45, 1172-1178.	1.0	5
94	Gas phenomenon in the superior space of the temporomandibular joint: report of a case. Journal of Oral and Maxillofacial Surgery, 2004, 62, 107-111.	0.5	5
95	Analysis of acceleration sensitivity in frequency decoupled MEMS tuning fork gyroscope. Procedia Engineering, 2011, 25, 51-54.	1.2	5
96	Development of piezoelectric MEMS deformable mirror. Microsystem Technologies, 2011, 17, 931-935.	1.2	5
97	Sacrificial microchannel sealing by glass-frit reflow for chip scale atomic magnetometer. Electronics and Communications in Japan, 2013, 96, 58-66.	0.3	5
98	Design, characterization and control of SMA springs-based multi-modal tactile display device for biomedical applications. Mechatronics, 2015, 31, 255-263.	2.0	5
99	Effect of crystallographic orientation on tensile fractures of (100) and (110) silicon microstructures fabricated from silicon-insulator wafers. Micro and Nano Letters, 2015, 10, 678-682.	0.6	5
100	A Planar Single-Actuator Bi-Stable Switch Based on Latch-Lock Mechanism. , 2019, ,		5
101	Novel microfluidic device integrated with a fluidic-capacitor to mimic heart beating for generation of functional liver organoids. Electronics and Communications in Japan, 2019, 102, 41-49.	0.3	5
102	Development of Microfabricated Capillary Array Electrophoresis Chip and Direct Observation of Dynamics of DNA Molecules Migrating in Microchannels. IEEJ Transactions on Sensors and Micromachines, 1999, 119, 460-463.	0.0	5
103	Mixing Speed- and Temperature-Controlled Microreactor for Gold Nanoparticle Synthesis. IEEJ Transactions on Sensors and Micromachines, 2010, 130, 292-299.	0.0	5
104	Component Modeling of 2DOF Comb Transducer for Equivalent Circuit Using Built-in Displacement Detection. IEEJ Transactions on Sensors and Micromachines, 2010, 130, 443-449.	0.0	5
105	Tensile-mode fatigue tests and fatigue life predictions of single crystal silicon in humidity controlled environments. , 2007, ,		4
106	Objective Function and Adjoint Sensitivities for Moving-Mask Lithography. , 2008, ,		4
107	Manipulation of DNA origami nanotubes in liquid using programmable tapping-mode atomic force microscopy. Micro and Nano Letters, 2013, 8, 641-645.	0.6	4
108	Large-displacement electrostatic deformable mirror using movable bottom electrodes. , 2014, ,		4

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109	A Drive-by-Microwave isolated gate driver with gate current charge for IGBTs. , 2014, , .		4
110	Elasticity measurement of DNA origami nanotube in liquid with tapping mode AFM. , 2014, , .		4
111	Constructing higher order DNA origami arrays using DNA junctions of anti-parallel/parallel double crossovers. Japanese Journal of Applied Physics, 2016, 55, 06GL04.	0.8	4
112	Time-Resolved Micro-Raman Stress Spectroscopy for Single-Crystal Silicon Resonators Using a MEMS Optical Chopper. Journal of Microelectromechanical Systems, 2016, 25, 188-196.	1.7	4
113	Measurement and potential barrier evolution analysis of cold field emission in fracture fabricated Si nanogap. Japanese Journal of Applied Physics, 2017, 56, 06GF06.	0.8	4
114	Geometrical compensation of (100) single-crystal silicon mode-matched vibratory ring gyroscope. , 2018, , .		4
115	Moving Mask Direct Photo-Etching (M2DPE) for 3D Micromachining of Polytetrafluoroethylene. IEEJ Transactions on Sensors and Micromachines, 2006, 126, 499-503.	0.0	4
116	Laser-driven optothermal microactuator operated in water. Applied Optics, 2020, 59, 1627.	0.9	4
117	MONOLITHIC PYROELECTRIC INFRARED IMAGE SENSOR USING PVDF THIN FILM. IEEJ Transactions on Sensors and Micromachines, 1997, 117, 607-611.	0.0	3
118	<title>Etching rate control of mask material for $XeF_2$ etching using UV exposure</title>. , 2001, 4557, 18.		3
119	Deep X-ray exposure system with multistage for 3D microfabrication. Journal of Micromechatronics, 2002, 2, 1-11.	1.9	3
120	Cellular automaton simulation of micropowder blasting with mask erosion. IEEJ Transactions on Electrical and Electronic Engineering, 2007, 2, 348-356.	0.8	3
121	The effect of polymer matrix on laser microfabrication of Au nanoparticles dispersed polymer resists. Applied Surface Science, 2008, 255, 2237-2243.	3.1	3
122	Extreme-low-power thermal convective accelerometer based on CNT sensing element. , 2009, , .		3
123	Extraction Equilibrium of Ethanol for Bioethanol Production " Solvent Selection and Liquid-liquid Equilibrium Measurement ". Journal of the Japan Petroleum Institute, 2010, 53, 135-143.	0.4	3
124	Self-dependent equivalent circuit modeling of electrostatic comb transducers for integrated MEMS. , 2011, , .		3
125	Investigation of Molecular Diffusivity of Photoresist Membrane using Coarse-Grained Molecular Dynamics Simulation. Procedia Engineering, 2012, 47, 402-405.	1.2	3
126	Rotational motion effect on sensitivity matrix of MEMS three-axis accelerometer for realization of concurrent calibration using vibration table. , 2013, , .		3



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127	Double-side-drive electrostatic optical chopper for time-resolved Raman spectroscopy. , 2014, , .		3
128	Experimental verification of frequency decoupling effect on acceleration sensitivity in tuning fork gyroscopes using in-plane coupled resonators. <i>Microsystem Technologies</i> , 2014, 20, 403-411.	1.2	3
129	An isolated DC power supply free compact GaN inverter module. , 2015, , .		3
130	Tensile test of a silicon microstructure fully coated with submicrometer-thick diamond like carbon film using plasma enhanced chemical vapor deposition method. <i>Japanese Journal of Applied Physics</i> , 2017, 56, 06GN01.	0.8	3
131	Low temperature, wafer-level process of alkali-metal vapor cells for micro-fabricated atomic clocks. , 2017, , .		3
132	Rhombicâ€Shaped Nanostructures and Mechanical Properties of 2D DNA Origami Constructed with Different Crossover/Nick Designs. <i>Small</i> , 2018, 14, 1702028.	5.2	3
133	DNA-DNA Origami. , 2015, , 589-603.		3
134	Process Simulation System for 3D X-Ray Lithography and Development. <i>IEEJ Transactions on Sensors and Micromachines</i> , 2003, 123, 368-375.	0.0	3
135	Out-of-plane Bending Vibration Fracture Test of Polycrystalline Silicon Thin-film Membrane. <i>IEEJ Transactions on Sensors and Micromachines</i> , 2012, 132, 224-229.	0.0	3
136	Novel Microfabricated Capillary Array Electrophoresis Chip Fabricated by Synchrotron Radiation and Direct Observation of Dynamics of DNA Molecules Migrating in Microchannels. , 1998, , 331-334.		3
137	Surfaceâ€enhanced Raman spectroscopy with gold nanoparticle dimers created by sacrificial DNA origami technique. <i>Micro and Nano Letters</i> , 2020, 15, 384-389.	0.6	3
138	Automated optimization of light dose distribution for moving-mask lithography. , 2009, , .		2
139	Configurable assembly of DNA origami on MEMS by microfluidic device. , 2011, , .		2
140	Equivalent circuit analysis of micromechanical resonator using comb transducer model with built-in displacement detection. , 2011, , .		2
141	Epoxy-based permeable membrane fabrication for 3D microfluidic device. , 2011, , .		2
142	mESC and hiPSC Proliferation on Negative Photoresists for Microfluidics. <i>Procedia Engineering</i> , 2011, 25, 1233-1236.	1.2	2
143	Fatigue Testing of Polycrystalline Silicon Thin-Film Membrane Using Out-of-Plane Bending Vibration. <i>Japanese Journal of Applied Physics</i> , 2012, 51, 11PA02.	0.8	2
144	Analytical investigation of the feasibility of sacrificial microchannel sealing for Chip-Scale Atomic Magnetometers. <i>Microsystem Technologies</i> , 2014, 20, 357-365.	1.2	2

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145	Direct characterization of radial modulus of DNA nanotube by AFM nanoindentation. , 2015, , .		2
146	MEMS deformable mirror actuated by electrostatic piston array. , 2016, , .		2
147	Effect of Crystallographic Orientations on Fractures and Slip Occurrences at 500 Å°C of (110) Single Crystal Silicon Microstructures. Procedia Structural Integrity, 2016, 2, 1413-1420.	0.3	2
148	Microfabrication of Embedding a Flexible Parylene-Based Microelectrode Array within Body-on-a-Chip. Proceedings (mdpi), 2017, 1, 302.	0.2	2
149	Mechanical and Electrical Clamping of DEP Assembled SWCNT Using Electroless Gold Deposition. IEEJ Transactions on Sensors and Micromachines, 2012, 132, 108-113.	0.0	2
150	High-Yield Bridged Assembly of ssDNA-Modified SWCNT Using Dielectrophoresis. International Journal of Automation Technology, 2018, 12, 29-36.	0.5	2
151	Clinical observation of osteoarthritis of the temporomandibular joint. Relation to internal derangement.. Nihon Koku Geka Gakkai Zasshi, 1991, 37, 118-126.	0.0	2
152	¼-CE Chip Fabricated by Moving Mask Deep X-ray Lithography Technology. , 2000, , 143-146.		2
153	Algorithm to Derive Optimal Mask and Movement Patterns in Moving Mask Deep X-ray Lithography (M2DXL). IEEJ Transactions on Sensors and Micromachines, 2005, 125, 222-228.	0.0	2
154	Deceleration of ion beams for film deposition by an electrostatic field. Nuclear Instruments & Methods in Physics Research B, 1989, 37-38, 906-909.	0.6	1
155	Low Temperature Preparation of SnO2 Film by Photo CVD with Sn(CH3)4-O2 or O3 System.. Hyomen Cijutsu/Journal of the Surface Finishing Society of Japan, 1994, 45, 547-548.	0.1	1
156	Damageless Magnetron Sputtering Deposition of SnO2:Sb Thin Films with Compensation Methods. Materials Research Society Symposia Proceedings, 1995, 403, 423.	0.1	1
157	A Surface Micromachined Resonant Accelerometer Based on Rigidity Change. IEEJ Transactions on Sensors and Micromachines, 1998, 118, 413-419.	0.0	1
158	Down-Sizing in Analytical Chemistry. Fabrication of a micro-channel chip for electrophoresis by using a Photosensitive epoxy resin as an etching mask.. Bunseki Kagaku, 2000, 49, 1037-1041.	0.1	1
159	Reduction in surface roughness and aperture size effect for XeF 2 etching of Si. , 2003, , .		1
160	Temperature Controlled Capillary Driven Sequential Stacking Self-Assembly using Two Different Adhesives. , 2007, , .		1
161	Effect of Surface Oxide Layer on Mechanical Properties of Single Crystalline Silicon. Materials Research Society Symposia Proceedings, 2007, 1052, 1.	0.1	1
162	Micro/Nano Assembly as a Key to SENS (Synthetic Engineering for Nano Systems). ECS Transactions, 2009, 16, 49-64.	0.3	1

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163	DNA-grafted-polymer mediated self-assembly of micro components. , 2010, , .		1
164	Coarse-Grained Molecular Dynamics Simulation of Epoxy-Based Chemically-Amplified Resist for MEMS Application. Materials Research Society Symposia Proceedings, 2012, 1415, 139.	0.1	1
165	Evaluation of strain gauge factors of graphene ribbon models based on first-principles electronic-state calculations. , 2012, , .		1
166	First-principles simulation on orientation dependence of piezoresistivity in graphene nanoribbon. , 2014, , .		1
167	Optimization methods for 3D lithography process utilizing DMD-based maskless grayscale photolithography system. Proceedings of SPIE, 2015, , .	0.8	1
168	FET properties of single-walled carbon nanotubes individually assembled utilizing single strand DNA. , 2015, , .		1
169	Investigation of the self-assembly process for discrete and polymerized bivalve DNA origami structures. IEEJ Transactions on Electrical and Electronic Engineering, 2016, 11, S164.	0.8	1
170	Photoresist Micro-Chamber for the Diffracted X-ray Tracking Method Recording Single-Molecule Conformational Changes. Procedia Engineering, 2016, 168, 1394-1397.	1.2	1
171	Microfabrication of Cs-filled MEMS cell using sequential plasma activated bonding. , 2017, , .		1
172	Thermomechanical noise of arrayed capacitive accelerometers with 300-NM-gap sensing electrodes. , 2017, , .		1
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